

DOI: [10.29026/oea.2024.230120C](https://doi.org/10.29026/oea.2024.230120C)

# Author correction: All-optical object identification and three-dimensional reconstruction based on optical computing metasurface

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Xu DY, Xu WH, Yang Q et al. Author correction: All-optical object identification and three-dimensional reconstruction based on optical computing metasurface. *Opto-Electron Adv* **7**, 230120C (2024).

Correction to: *Opto-Electronic Advances*

<https://doi.org/10.29026/oea.2023.220120>

published online 26 April 2023

After the publication of this article<sup>1</sup>, it was brought to our attention that a label unit in [Figure 4](#) contained a mistake, leading to an inaccurate value. The units in [Figure 4](#) are not ‘mm’ but ‘cm’ instead. Correction details are listed below.

1. The note in [Figure 4](#) “Scale bar, 200  $\mu\text{m}$ ” should be “Scale bar, 2000  $\mu\text{m}$ ”

2. [Figure 4](#) is replaced exhibiting the accurate units;

We would like to apologize for any inconvenience these errors may have caused.

The original article has been updated.

## References

1. Xu DY, Xu WH, Yang Q et al. All-optical object identification and three-dimensional reconstruction based on optical computing metasurface. *Opto-Electron Adv* **6**, 230120 (2023).

## Competing interests

The authors declare no competing financial interests.

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Published online: 25 April 2024



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